

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Shunichi SEKI, Hiroshi KIGUCHI, Ichio YUDASAKA and Hiroo MIYAJIMA

Rule 53(b) Continuing Application of  
U.S. Application No. 09/423,969

Filed: October 17, 2003

Docket No.: 104741.01

For: METHOD OF FORMING THIN FILM PATTERNING SUBSTRATE INCLUDING  
FORMATION OF BANKS (AS AMENDED)

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please consider the following:

**Amendments to the Specification; and**

**Remarks.**